Attorney Docket No.: 61994.00013

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner:

Leonardo Andujar

Lawrence Liu et al.

Serial No.:

10/807,795

Art Unit:

2826

Filed:

March 23, 2004

Title:

Method and Structure in the Manufacture of Mask Read Only Memory

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement dated March 27, 2006, Applicants elect Group II drawn to claims 8 – 23.

The undersigned authorizes any fees which may be required, or credit any overpayment to Deposit Account No. 05-0150. Should the Examiner have any questions regarding this communication, the Examiner is invited to contact the undersigned at the telephone number shown below.

Date:

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Respectfully submitted, Lawrence Liu et al